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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hideharu ITATANI et al.

Group Art Unit: 2891

Application No.: 10/521,248

Filed: April 11, 2005

Docket No.: 122430

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND SUBSTRATE  
PROCESSING APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 1-10.
- 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- 4. An English language Abstract of one or more non-English language reference is attached hereto. See References 5, 6, & 8-10.

5. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 8 & 10.

Respectfully submitted,



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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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Sheet 1 of 1

Form PTO-1440 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 122430	APPLICATION NO. 10/521,248	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)		APPLICANTS Hideharu ITATANI et al.				
				FILING DATE April 11, 2005	GROUP 2891	
U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No.	Document Number	Date	Name		
	1	US 6,143,659	11/7/2000	Leem		
	2	US 5,306,666	4/26/1994	Izumi		
	3	US 5,789,321	8/4/1998	Ohshita		
	4	US 2001/0054769	12/27/2001	Ivo et al.		
FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract <input checked="" type="checkbox"/>	With English Translation <input type="checkbox"/>
	5	JP A 04-361531	12/15/1992	Japan	<input checked="" type="checkbox"/>	
	6	JP A 01-204434	8/17/1989	Japan	<input checked="" type="checkbox"/>	
	7	EP 1 130 628 A1	9/5/2001	Europe		
	8	JP A 09-260373	10/3/1997	Japan	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
	9	JP A 04-198484	7/17/1992	Japan	<input checked="" type="checkbox"/>	
	10	JP A 2000-144421	5/26/2000	Japan	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>
OTHER DOCUMENTS						
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)				
EXAMINER					DATE CONSIDERED	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						